

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shinji NAKAMURA et al.

Application No. 09/680,054

Filed: October 5, 2000

For: SEMICONDUCTOR DEVICE,  
SEMICONDUCTOR SUBSTRATE,  
AND MANUFACTURE METHOD

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Group Art Unit: 2823  
Examiner: Brook Kebede  
Confirmation No. 7323  
Date: March 3, 2004  
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CERTIFICATE OF MAILING OR TRANSMISSION  
[37 CFR 1.8(a)]

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Signature: \_\_\_\_\_  
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AMENDMENT

Mail Stop **BOX AF**  
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Sir:

In response to the Office Action dated December 3, 2003, please amend the above identified application as follows.